

Notice of References Cited	Application/Control No. 10/602,415		Applicant(s)/Patent Under Reexamination LIU ET AL.	
	Examiner Jung Park		Art Unit 2616	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2001/0028780	10-2001	NA et al.	386/46
*	B	US-5,920,572	07-1999	Washington et al.	370/535
*	C	US-6,434,171	08-2002	Ishida, Tadahiro	370/537
*	D	US-6,999,424	02-2006	Kovacevic et al.	370/252
*	E	US-2001/0009548	07-2001	Morris, Octavius J.	370/392
*	F	US-2001/0033619	10-2001	Hanamura et al.	375/240.26
*	G	US-2003/0035649	02-2003	Chung et al.	386/111
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.